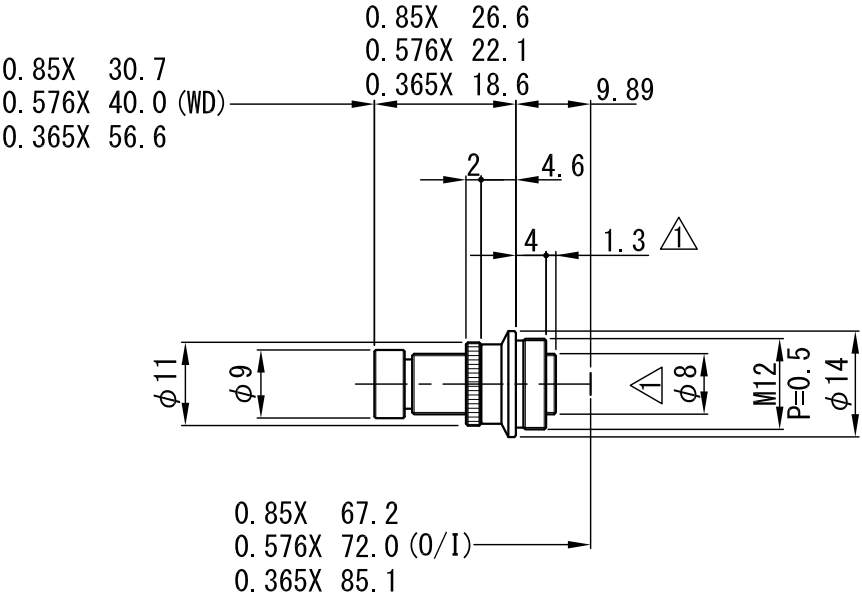




△×				APPROVED	CHECKED	MATERIAL 材料				—		CHAMFER 一般面取		—		~~QUANTITY 個数~~	
△×				T. A.	T. T.	TREATMENT 処理				—		FINISHING 仕上		—		<del></del>	
△×						TREATMENT CONTACT 処理接点				—		DECENTRATION 偏芯		—			
△×				DESIGNED	DRAWN	OVER 250 UP TO 1000 ±0.3 ±0.5 ±1.0 ±0.2				UNIT (mm)	ANGLE 角度	METHOD 図法	REMARK 適用 (機種名)				
△×						OVER 63 UP TO 250 ±0.2 ±0.3 ±0.6 ±0.15					—		V S - M C 0 5 7 6 N				
△× 2	寸法追記	20.04.09	T. T.			OVER 16 UP TO 63 ±0.1 ±0.2 ±0.4 ±0.1				SCALE	1 / 1		NAME	外 観 図			
NO.×箇所	REVISION 訂正事項	DATE	NAME			OVER 0 UP TO 16 ±0.05 ±0.1 ±0.2 ±0.1					DATE		13.05.30		DRAW NO.	O D M C 0 3 4 0 A 2	
						~~TOLERANCES A B C S~~											